



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of

TSUCHIYA et al.

Application Number: 10/750,882

Filed: January 5, 2004

**For: METHOD FOR PRODUCING NANOPARTICLE
LAYER HAVING UNIFORM EASY AXIS OF
MAGNETIZATION, MAGNETIC RECORDING
MEDIUM HAVING SUCH LAYER, ITS PRODUCTION
METHOD, AND ITS PRODUCTION APPARATUS**

Attorney Docket No. HITA.0482

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

Art Unit 1773

Examiner Holly C. Rickman

RESPONSE AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

This is in response to the Final Office Action mailed on October 18, 2006, the period of response to which is set to expire on February 18, 2007, with the payment of the appropriate government extension fee for one month. Please amend the above-referenced application as follows: